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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10570645
	Filing Date		2006-03-03
	First Named Inventor	Hilmar Gugel	
	Art Unit	2872	
	Examiner Name	A. C. Lavarias	
Attorney Docket Number		20793/0204537-USO	

U.S.PATENTS						
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1	6958470		2005-10-25	Hoffmann et al.	
	2	6285019		2001-09-04	Engelhardt et al.	

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	1	10105391	DE		2002-08-29	Leica Microsystems	Corresponds to US 6,958,470	<input type="checkbox"/>
	2	9828646	WO		1998-07-02	Leica Lasertechnik et al.	Corresponds to US 6,285,019	<input type="checkbox"/>

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